

Electronic Acknowledgement Receipt

EFS ID:	1041375
Application Number:	10615794
Confirmation Number:	3511
Title of Invention:	Void-free damascene copper deposition process and means of monitoring thereof
First Named Inventor:	Panayotis Andricacos
Customer Number:	30678
Filer:	John A. Evans/Lisa Hawkins
Filer Authorized By:	John A. Evans
Attorney Docket Number:	20140-00302-US /YOR920030
Receipt Date:	08-MAY-2006
Filing Date:	10-JUL-2003
Time Stamp:	16:02:17
Application Type:	Utility
International Application Number:	

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		20140-302-US-050806Amd.pdf	116174	yes	8

	Multipart Description		
	Doc Desc	Start	End
	Amendment After Final	1	1
	Claims	2	4
	Applicant Arguments/Remarks Made in an Amendment	5	8

Warnings:	
Information:	
Total Files Size (in bytes):	116174

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111
If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371
If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.